CAV 2822#



PATENT 740756-1551

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

Shunpei YAMAZAKI et al.

Application No.:

08/691,434

Filed:

August 2, 1996

For:

METHOD FOR FABRICATING

SEMICONDUCTOR DEVICES

AND APPARATUS FOR

PROCESSING A SEMICONDUCTOR)

Art Unit: 2822

Examiner: M. Wilczewski

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.O. 20231, on

TRANSMITTAL LETTER

Commissioner for Patents Washington, D.C. 20231

January 29, 2001

Sir:

Transmitted herewith is an Amendment Under 37 C.F.R. § 1.111 in the above-identified application.

The fees have been calculated as shown below:

	Claims		Highest	Present		<i>i</i> = .
	Remaining		Number	Extra	Small/Large	
	After		Previously		Entity	100H Fee
	Amendment	:	Paid For		Rate	Fee
Total	85	Minus	85	0	x \$9/\$18	\$0.00
Indep	15	Minus	15	0	x \$39/\$78	\$0.00
First Presentation of Multiple Dependent Claim + \$130/\$260						\$0.00
TOTAL						\$0.00

Application No.: 08/691,434 Attorney Docket No.: 740756-1551

Art Unit: 2822 Page 2

[X] A Petition for Extension of Time for Two (2) Month and an Information Disclosure Statement is enclosed.

- [X] A check in the amount of \$570.00 to cover the extension of time and Information Disclosure Statement fees.
- [X] In the event applicant(s) has overlooked the need for any petition and fee for extension of time, and such extension is required, applicant(s) requests that this be considered a petition therefor and that such fee be charged to Deposit Account No. 19-2380 (0756-1551).
- [X] The Commissioner is hereby authorized to charge fees under 37 CFR 1.16, 1.17, 1.20(a), 1.20(b), 1.20(c) and 1.20 (d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380 (0756-1551). A duplicate copy of this sheet is attached.

Respectfully submitted,

NIXON PEABODY LLP

Eric J. Robinson

Reg. No. 38,285

EJR/LCD/dlt

8180 Greensboro Drive, Suite 800

McLean, Virginia 22102

Telephone: (703) 790-9110 Facsimile: (703) 883-0370

#52/Response Upnrum 2/10/0/ PATENT 740756-1551

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Art Unit: 2822

Examiner: Mary Wilczewski

CERTIFICATE OF MAILING

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<u>AMENDMENT</u>

Commissioner of Patents Washington, D.C. 20231

January 29, 2001

Dear Sir:

In response to the Examiner's non-final Office Action mailed August 29, 2000, the period for responding having been extended two (2) months, please consider the following remarks in connection with the above-identified application.

REMARKS

At the outset, the Primary Examiner is thanked for her thorough review and consideration of the present application.

The Examiner's non-final Office Action dated August 29, 2000 has been received and its contents carefully noted. Claims 16-20, 24, 25, 56-61 and 74-91 are pending in the present application, of which 16, 21, 26, 32, 38, 44, 50, 56, 62, 68, 74, 75, 76, and 77 are independent.